

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/652,862	CHANG ET AL.	
Examiner	Art Unit	
James D. Ewart	2617	

	SEARCHED				
Class	Subclass	Date	Examiner		
455	12.1	4/24/2006	JDE		
	13.1				
	427				
	429				
	456				
	458				
	562				
342	357.01				
	357.16	,			
	457	_			
244	158R				

INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
above	4/24/2006	JDE		
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	Subclass	Subclass Date		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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